Technical Meeting on Emerging applications of Plasma Science and Technology

Plasma diffusion treatments and coatings for industrial applications

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प्लाज़्मा अनुसंधान संस्थान Institute for Plasma Research

ABOUT

INSTITUTE FOR PLASMA RESEARCH (IPR)

सहायता पाप्त संस्थान परमाणु ऊर्जा विभाग **GRANT-IN-AID INSTITUTIONS** DEPARTMENT OF ATOMIC ENERGY मानद विश्वविद्यालय तथा बोर्ड DEEMED UNIVERSITY AND BOARDS इलाहाबाद ALLAHABAD हरीश-चंद्र अनुसंधान संस्थान HARISH-CHANDRA RESEARCH INSTITUTE गाँधीनगर GANDHINAGAR प्लाज़्मा अनूसंधान संस्थान **INSTITUTE FOR PLASMA RESEARCH** कोलकाता KOLKATA मुंबई MUMBAI साहा नाभिकीय भौतिकी संस्थान टाटा मूलभूत अनुसंधान संस्थान SAHA INSTITUTE OF NUCLEAR PHYSICS TATA INSTITUTE OF FUNDAMENTAL RESEARCH टाटा स्मारक केंद्र भूबनेश्वर BHUBANESWAR TATA MEMORIAL CENTRE परमाणु ऊर्जा शिक्षण संस्था भौतिकी संस्थान ATOMIC ENERGY EDUCATION SOCIETY INSTITUTE OF PHYSICS होमी भाभा राष्ट्रीय संस्थान राष्ट्रीय विज्ञान शिक्षा एवं अनुसंधान संस्थान HOMI BHABHA NATIONAL INSTITUTE NATIONAL INSTITUTE OF SCIENCE EDUCATION AND RESEARCH परमाणु विज्ञान अनुसंधान बोर्ड चेन्नई CHENNAI BOARD OF RESEARCH IN NUCLEAR SCIENCES गणित विज्ञान संस्थान राष्ट्रीय उच्चतर गणित बोर्ड THE INSTITUTE OF MATHEMATICAL SCIENCES NATIONAL BOARD FOR HIGHER MATHEMATICS

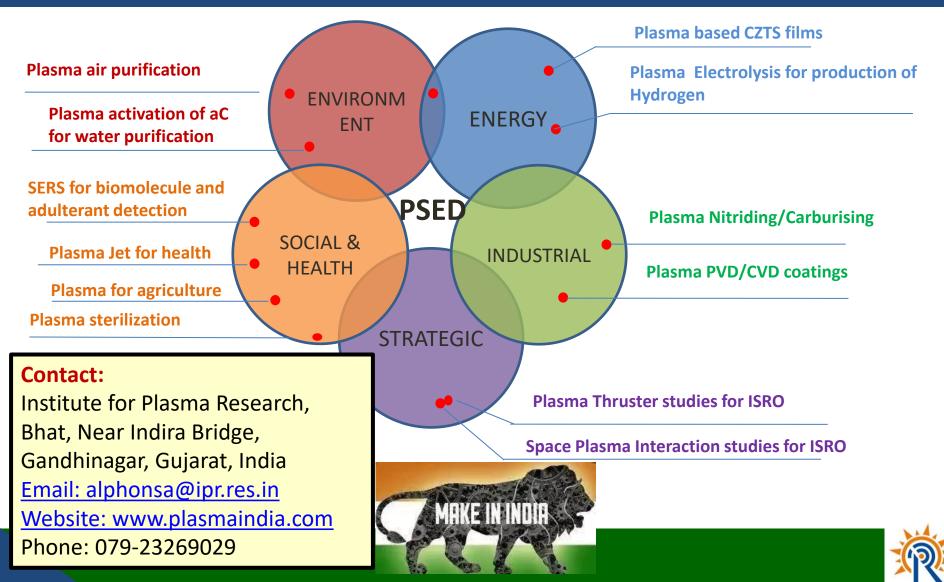
Discalimer: Creative graphics, map only a visual aid to indicate locations of DAE Units and Institutions in India



ABOUT IPR



PLASMA SURFACE ENGINEERING DIVISION @ IPR



OUTLINE

- BACKGROUND
- INTRODUCTION
- DIFFUSION BASED PROCESSES CASE STUDIES
 - Plasma Nitriding / Plasma Nitrocarburizing
 - Plasma Carburizing/ Plasma Carbonitriding
- DEPOSITION PROCESSES
 - Plasma Assisted PVD
 - Plasma Assisted CVD
- Conclusion



Industrial Requirement





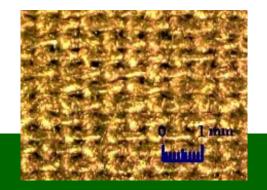






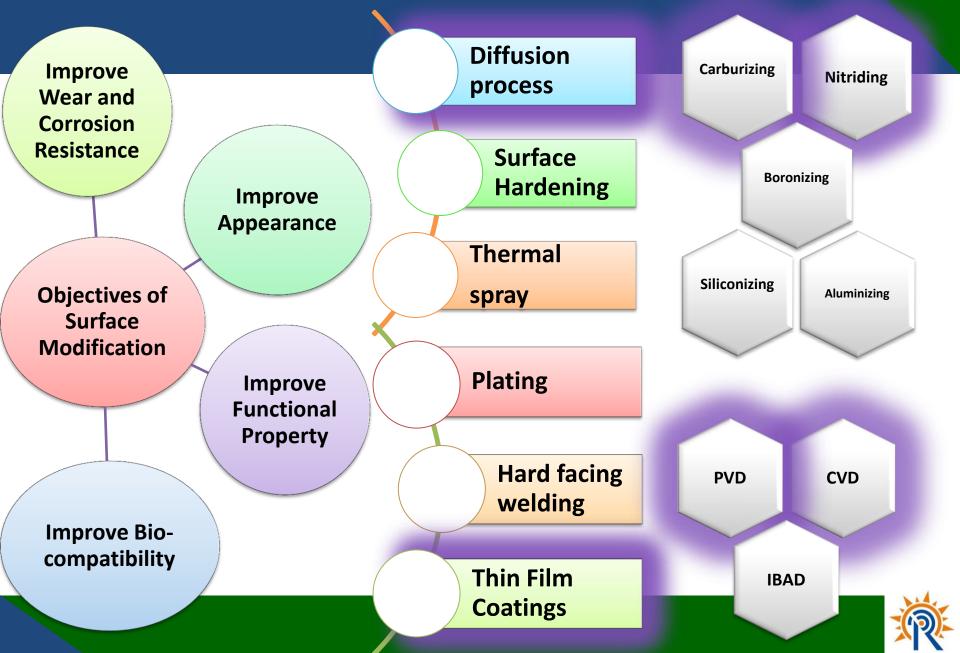








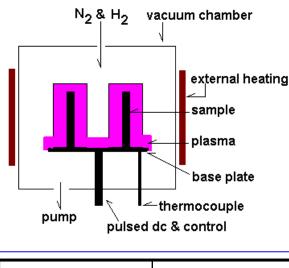
Surface Modification



About Plasma Nitriding

- Plasma Nitriding diffuse nitrogen in the subsurface of steel components (<u>few</u> <u>100 microns</u>)
- Use high temp (~ 550 C)
- Uniform abnormal glow discharge plasma environment
- Glow created by high negative bias (-600 V)
- p ~ few mbar
- Typical duration: 24 hrs
- Enhancement of
 - Surface hardness
 - Wear resistance
 - Corrosion resistance

Thereby increases component life



Process Parameters	Typical Range
Voltage	- 400-650 V
Current Density	1-5 mA/cm ²
Frequency	10-30 KHz
Temperature	400-570 °C
Pressure	3-5mbar



Plasma glow around components; Note the uniform plasma covering the component



NO HARMFUL EMISSION OF CHEMICALS

PN Systems @ IPR











Different configurations (4)



Scaled up



Transferred Technologies (4)



Installations (11)



PN for Space Sector

Gears and Pinion used in DM

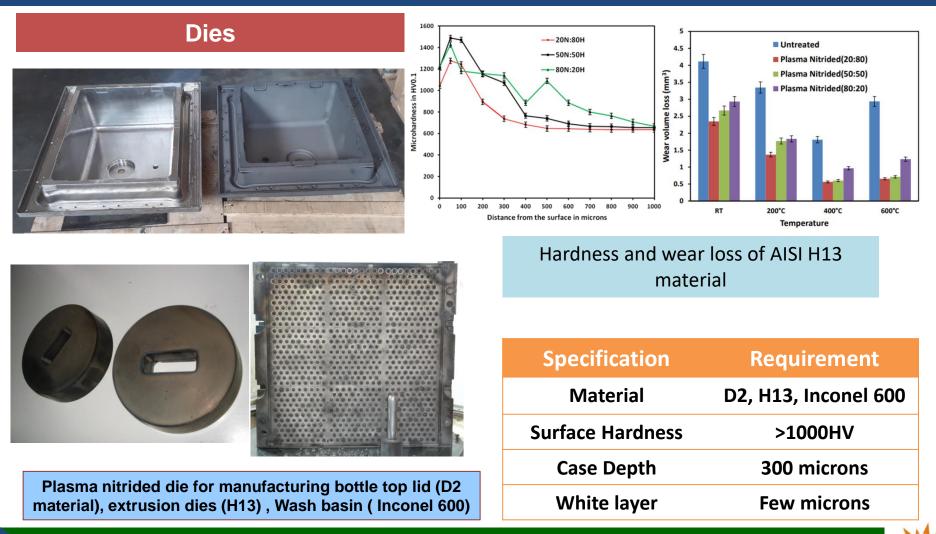
Objective:

Drive Assembly (DA) is a key component of space crafts sustains and rotate the solar arrays for sunlight acquisition, as well as transfer power and signals from solar array to spacecraft body.

		Specification	Requirement
Plasma nitrided gears	Material	17-4PH SS	
	Surface Hardness	s >800HV	
和短期	and pinions	Case Depth	100 microns
	(17-4PH material)	White layer	Absent
	Plasma nitriding of gears and pinions for INSAT	No White layer	
	satellite		Distance from the surface in mildrons

Plasma sciences and the creation of wealth, PI John, 2005, Tata McGraw-Hill Pub. Co.

PN of Dies

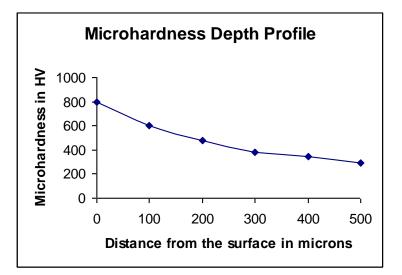


A. Kumar, et al. , **High-temperature tribological** studies of plasma-nitrided tool steels, Surface Engineering, 2017, 1-14

Plasma Nitriding for Automobile and machine tools sector



Specification	Requirement
Material	AISI 4140, En41B
Surface Hardness	>800 HV, >1000HV
Case Depth	300 microns



A WIDE VARIETY OF AUTOCOMPONENTS ARE ROUTINELY PLASMA NITRIDED IN THE INDUSTRY

Mukherjee S., Industrial Applications of Plasma Nitriding, Transactions of the Indian Institute of Metals. Vol. 58, no. 5. Oct. 2005.



PN of CTC roller in Tea Industry



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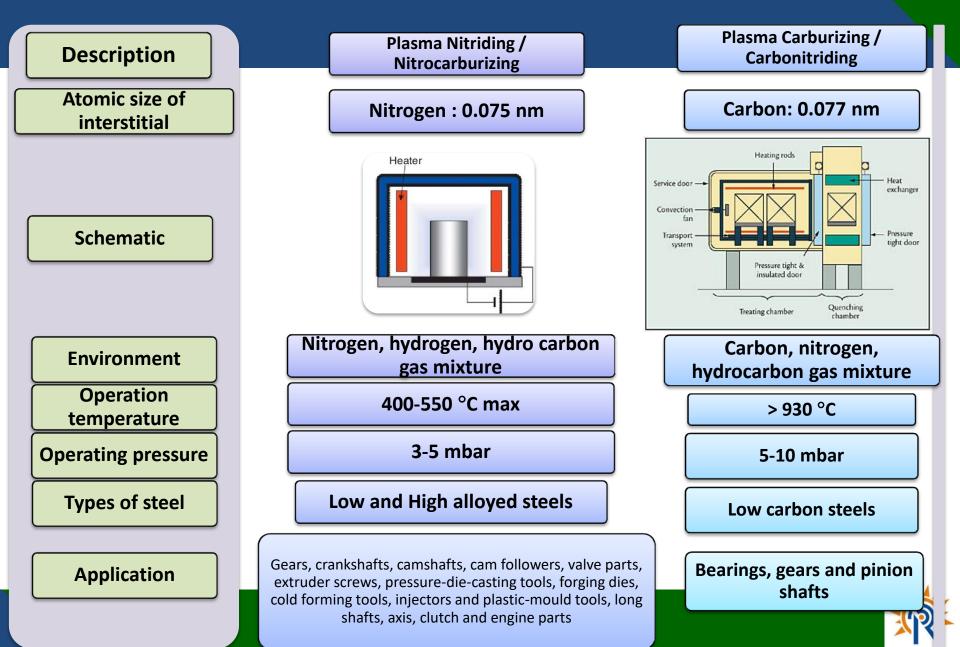


Plasma Nitriding System Installations

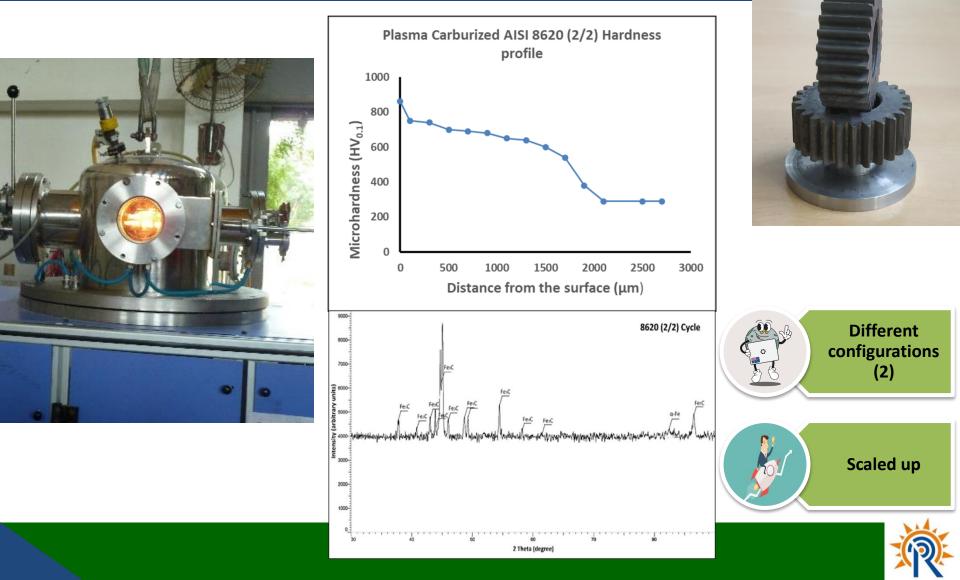




Plasma Nitriding and Carburizing (PC)



Plasma carburizing @ IPR



Plasma Assisted Physical Vapour Deposition (PAPVD)



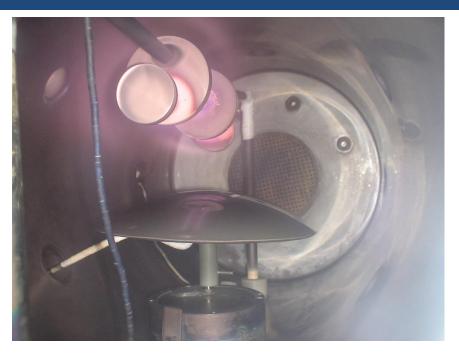
PVD system in IPR



- Different <u>control parameters</u> to develop special coatings.
- Ability to coat <u>heat sensitive</u> substrates.
- Circular, Rectangular or cylindrical Magnetrons available.
- <u>Up scaling</u> for large area coatings is possible



PAPVD coating for space applications



Physical Vapour Dep. Sputter = Copper P = 10 microbar Gas = Argon Sputter bias = -800 V Substrate bias = pulsed - 1 kV



Lexan

Cu coating

Copper coating

Thickness : 8 micron Application : Low weight antenna for Microwave reflectivity.



Performance of Implantable device :

- Bulk material (mechanical properties)
- Surface properties of used biomaterial (wear and biocompatibility)

Metals are prone to corrosion and wear

wear of the articulating components – primary reason for failure. Released Cr and Ni ions from the SS or Co-Cr metal can cause allergic reactions

<u>Ceramics</u> are prone to crack under heavy load even though wear rate is less

One of the approach to improve <u>surface characteristics</u> is

Deposition of biocompatible, wear resistant and corrosion resistant coatings

Coating materials : Titanium Nitride (TiN), TiNbN,

Diamond like coating (DLC) etc.



TiN coating for Hip Implant



Titanium Nitride (TiN) is interested choice

- high chemical stability
- high hardness
- excellent wear properties
- Good bio-Compatibility
- Good wettability by body fluids
- Approved by FDA

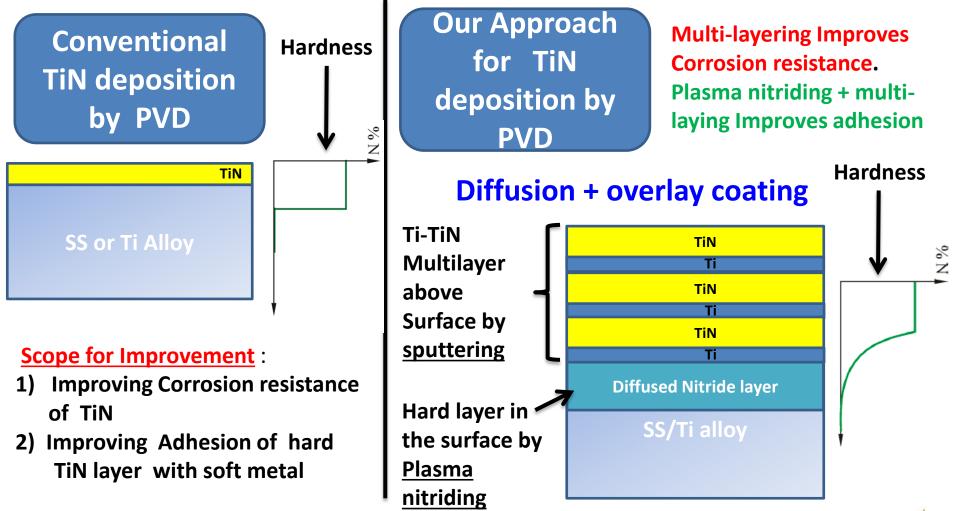
TiN can be deposited on Stainless Steel (SS) Titanium Alloy or Co-Cr alloys

Adhesion of the coating (TiN) with the Substrate (SS) is important factor for long term Performance of the implant.

Different PVD methods are used to produce these ceramic coatings on metal substrate. <u>Plasma based PVD method</u> is used to deposit these coatings on Implant

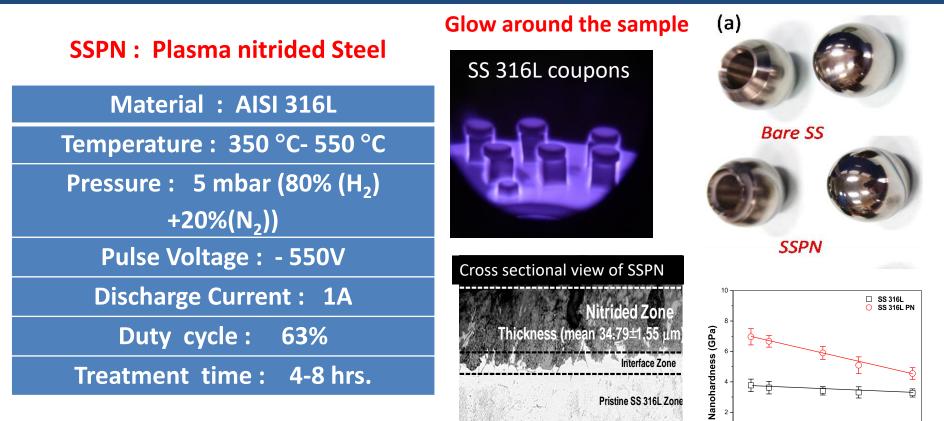


Our Approach for Surface Modification





Plasma Nitriding of SS femoral head



Uniform Treatment all over the surfaceHardness increases after plasma nitriding

hardening up to few micron inside the sample

Hardness at different load

Load (mN)

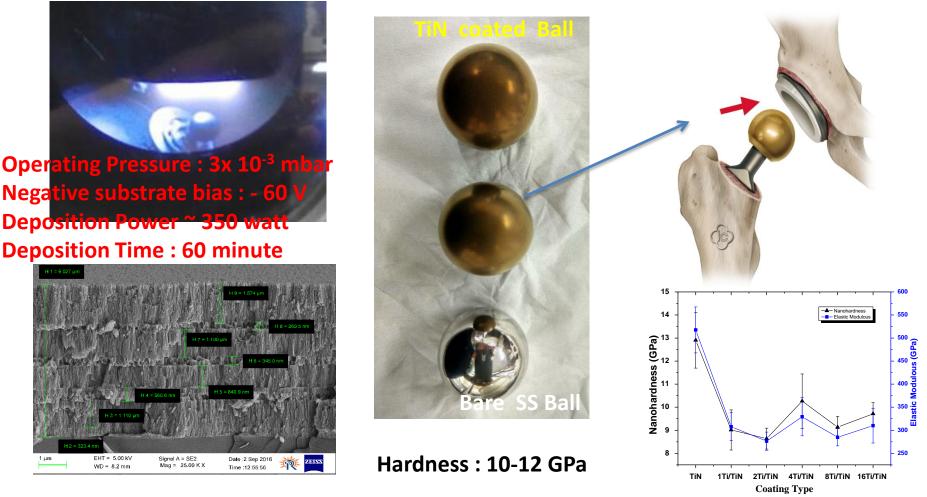
200



1000

800

Ti/TiN Coating : Hip Implant SS femoral head



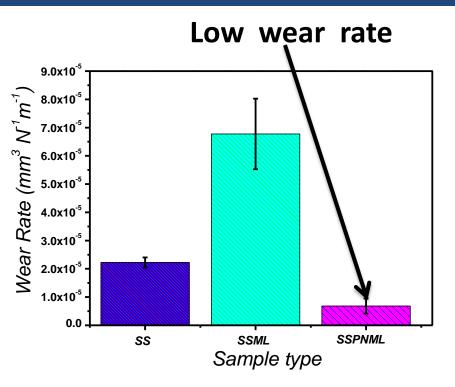
Thickness : 6 micron (8 Layers,

4- Ti and 4- TiN layers

A. Samata et al. Journal of the Mechanical Behavior of Biomedical Materials 77 (2017) 267-294.

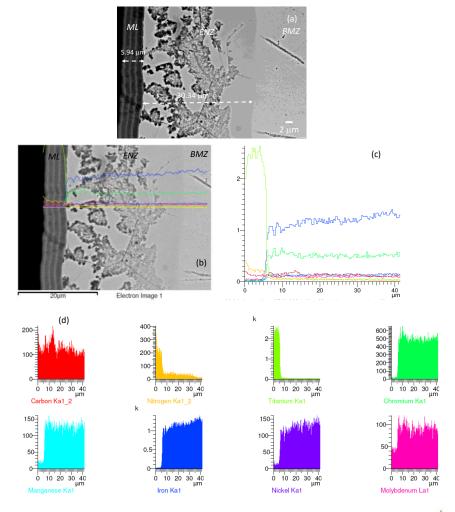


Nitriding + Coating : Duplex Surface Engineering



Wear rate in Simulated Body Fluid (SBF)

SS: Without any Plasma treatment SSML: Multilayer coating on SS SSPNML: Nitriding + Multilayer coatings





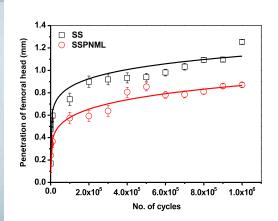
Aniruddha et al. Applied Surface Science 507:145009.

Preclinical Evaluation of wear using Hip-Joint Simulator machine



Frequency of load cycle : 1 Hz Testing up to 10⁶ cycles Fluid : SBF

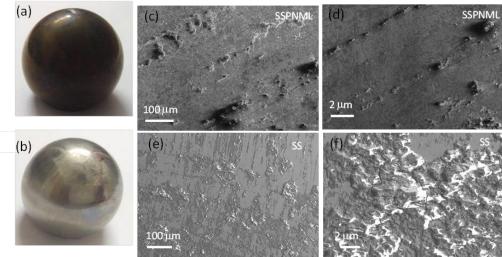
Load : identical to that experienced by the normal hip of a person with a body weight of about 100 kg.





(b)

Volumetric wear rate of UHMWPE cup For SS : 120-130 mm³/million cycle For SSPNML : 40-50 mm³/million cycle

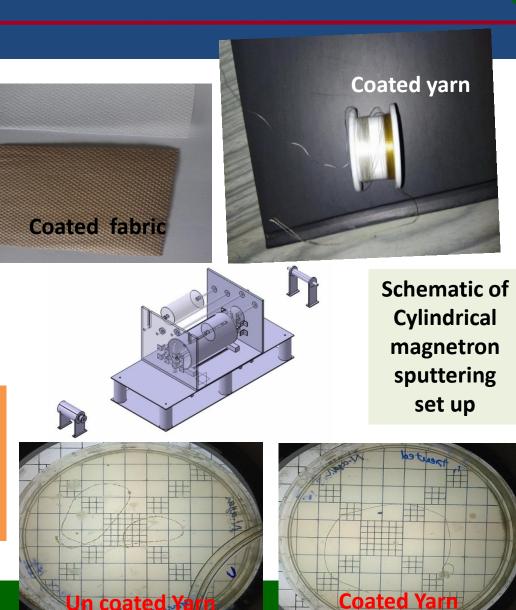




Antimicrobial coatings on yarn and fabric

Major Achievements

- Cylindrical magnetron sputtering for copper oxide Coating.
- Antibacterial/antiviral testing done
- Uniform coating on yarn
- Existing Speed of the coating for yarn : 5 mtr/min
- Deposit CuO coating in nanometer range (50-100nm) on moving yarn and fabric (woven/non-woven).
- Indian Patent application number: 202321003767 (2022)



Plasma Assisted PVD

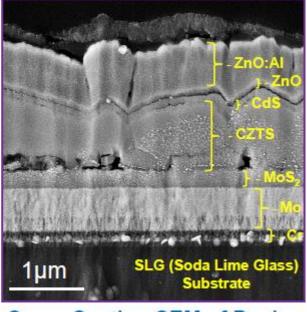


Multi-magnetron sputtering system in IPR



Development of CZTS (Cu₂ZnSnS₄) absorber based thin film solar cell on glass & flexible substrate





Cross Section SEM of Device



Challenge on adhesion was overcome by chemical and plasma cleaning for depositing CZTS based solar cell on Flexible steel substrate

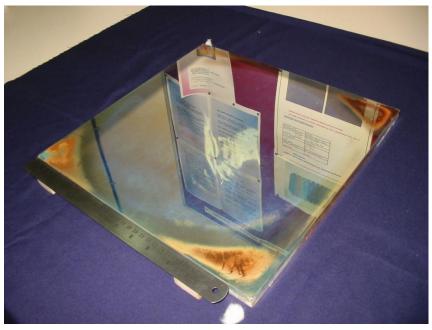
This can be used portable charging devices and to convert roof tops into solar cell for remote areas after achieving higher efficiency

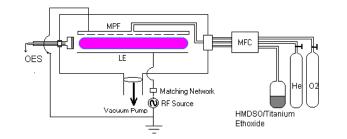


Plasma Assisted Chemical Vapour Deposition at IPR

SiOx Coating by Plasma Polymerization







Deposition experiments were carried out using an organic precursor with nitrogen gas on Aluminium mirrors.

Thickness of the deposited film were few hundred A°, with good uniformity over the substrate area. Film is transparent on the mirror surface

Fig. 1:Schematic of the experimental set-up. (i) Lp= langmuir probe, (ii) LE= live electrode, (iii) MPF= multi-point gas freeder, (iv) MFC= mass flow controllers



ANTI TARNISH COATINGS ON DECORATIVE ITEMS AND HEADLIGHTS



SiOx COATING ON BRASSWARE



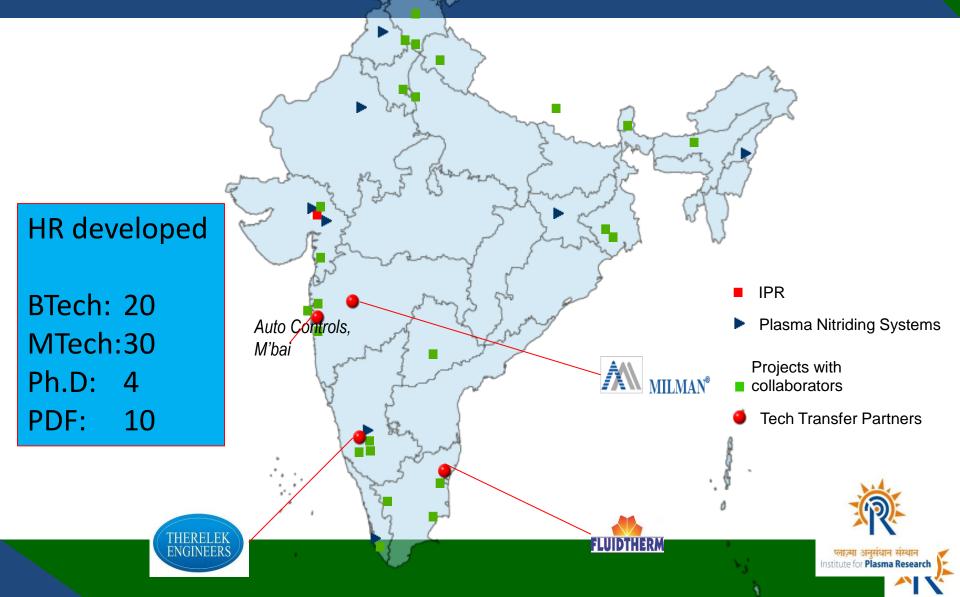


System installed in Moradabad, Uttar Pradesh

SiOx COATING ON HEADLIGHT



TECHNOLOGY TRANSFERS BY IPR ACROSS INDIA



Conclusion

- Plasma Nitriding , Plasma nitrocarburizing process and PA deposition processes have gained maturity and are being regularly used by customers.
- Plasma based surface modification modifies material surface in an environment friendly way.
- The life of steel components improved by a factor of 2 depending on the application.
- Based on our results, the TiN coated Ti alloy Femoral head can be used for clinical trials as the wear rates are in acceptable range.
- Plasma based technologies have reached to a mature and deployable level for commercialization to fulfill our country's mission of Make-in-India.



Challenges and Opportunities ahead

Challenges

- Existing polluting technologies, as there are no strict environment regulations.
- Reduced Power consumption.
- Coating / Diffusion Techniques using atmospheric pressure plasma.

Opportunities

- Clean Technology as no residues are found after the process
- > No environmental clearance required.
- > Applicable to all types of Ferrous, Al, Ti, Cr materials
- Beneficial to many industrial sectors like, automobiles, dies, textile, space, machine tools etc.



Acknowledgment



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THANK YOU HAPPY TO TAKE YOUR QUESTIONS!

CONTACT US @ Project Technology Transfer Section INSTITUTE FOR PLASMA RESEARCH

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